

SIEMENS

DO NOT ENTER: /M.G.M./

05/24/2008

PATENT
Attorney Docket No. 2001P05854US02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventor: Ralf Buergel, et al.) Group Art Unit: 1792
)
Serial No.: 10/786,349) Examiner: Michael G. Miller
)
Filed: 02/25/2004) Confirmation No.: 4552

Title: METHOD FOR RESTORING THE MICROSTRUCTURE OF A TEXTURED
ARTICLE AND FOR REFURBISHING A GAS TURBINE BLADE OR VANE

MAIL STOP AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR 1.116

Sir:

In response to the Final Office Action mailed March 18, 2008 Applicants respectfully submit the following amendment and remarks in connection with the above-identified application.

Entry of this paper is respectfully requested in order to overcome the rejections under 35 USC 112. Reconsideration of the rejections under 35 USC 102 and 103 are respectfully requested in view of the Remarks provided below.

(Please proceed to page 2)